

Learning Microsystems Through Problem Solving: Procedure Checklist – Procedure I

✓	Task	Comments
	1. <u>Select a problem</u> to solve.	Refer to Learning Microsystems Through Problem Solving Challenge Problems
	2. Write a <u>problem statement</u> .	<i>e.g., A MEMS designed to detect the H1N1 virus in the field or at home would require a sensing component that would detect ONLY the H1N1 virus while ignoring other analytes in the sample.</i>
	3. List the <u>variables</u> associated with this problem.	What will the device sense? What will change? (<i>e.g., The H1N1 sensing component would "sense" the presence of the H1N1 virus in a small amount of saliva from a mouth swab placed on an "application point "on the MEMS device. The sensing component would react to the presence of the virus by indicating a change in one or more of the component's operating parameters such as its position, resistance, frequency, temperature, etc.)</i>)
	4. List the <u>criteria</u> to which you will base your design.	Size, versatility, transducing capability, electronic interface, etc. (<i>e.g., The H1N1 MEMS must be portable, small enough to be easily integrated into a handheld unit, sensing element will be disposable, self-powered, easy to use.</i>)
	5. What <u>assumptions</u> did you make when determining your variables and criteria?	<i>e.g., It was assumed that (a) enough of the H1N1 virus could be found in a small sample such as the saliva from a swab (b) a probe coating could be develop by our bio-chemical engineers to detect and isolate the H1N1 virus, (c) a micro battery will be used to power the device.</i>
	6. Choose the <u>MEMS component</u> that you will design and build.	Refer to the component description cards provided. (<i>e.g., It was determined that a Surface Acoustic Wave (SAW) micro device could be used to identify the H1N1 virus. A SAW will detect a shift in the resonance frequency of an acoustical wave due to mass loading. The shift is created when the surface wave crosses over a variable surface, in this cause a coated gold film that detects and captures the H1N1 virus.</i>)
	7. State the <u>inputs (variable and fixed) and outputs</u> of the MEMS component.	Inputs and outputs depend on the type of component. Inputs/outputs may be different for a transducer vs. an actuator. (<i>e.g., <u>Inputs</u>: The variable input (sample) to the SAW component is a liquid solution containing the swabbed saliva. A fixed input is an acoustic wave generated by an input transducer. <u>Outputs</u>: A transducing receiver that can measure the frequency shift of the acoustical wave caused by the sample H1N1 viruses captured on the functionalized surface.</i>)
	8. <u>Create your design</u> : a. List the parts of your MEMS component b. Make a rough drawing of the component (show inputs/outputs)	<i>e.g., The parts of the SAW component are the (a) input and output transducers that generate and receive the acoustical wave, (b) a probe coating that captures the analytes (i.e., the H1N1 virus) from the sample.</i>
	9. Identify the <u>component layers</u> . a. <u>Create a mask set</u> : one mask for each layer (optional)	<i>e.g., SAW component – substrate, piezoelectric material, transducer electrodes and sensor plate, probe coating layer, and microfluidic channel cap.</i> See the procedure for a list and description of layers used for MEMS.
	10. <u>Build a model</u> of your device	Use the supplies provided. Using the information that you have developed, build a model of your MEMS component. You may use any and all of the materials in the supply box.

Learning Microsystems Through Problem Solving : Procedure Checklist – Procedure II

✓	Task	Comments
	11. <u>Create a process flow chart</u> to fabricate your device	Use the process cards in your supply box to construct your flowchart. See procedure for example related to the SAW component.
	12. <u>Describe the manufacturing process(es)</u> required for creating the device	Refer to the process description cards provided.
	13. Describe the <u>packaging</u> for the MEMS.	How will this MEMS interface with the user? How will the product be used? (e.g., The H1N1 portable detection unit will be hermetically sealed. The test for the virus, the user will removed a seal from the "input", then roll swab on the input pad. After a designated amount of time, the output will indicate Red (virus possibly present – see a doctor) / Green (no virus detected).
	14. Describe the <u>testing</u> requirements for your MEMS. (optional)	What tests are required to test the effectiveness of your MEMS? (e.g., Because this is a biomedical device, it would be required to follow the FDA regulations for biomedical approval. This approval entails several stages of testing from animal testing, to a small group of human subjects to larger groups of human subjects. For more information on this, please see the <u>SCME BioMEMS Regulations Learning Module.</u>)
	15. Describe the <u>advantages and disadvantages</u> of your MEMS compared to current method(s). (optional)	What are the advantages/disadvantages of your MEMS compared to current method(s)? (If applicable) What is the benefit of using a MEMS to solve this problem? (e.g., According to the Center for Disease Control and Prevention, testing for H1N1 is determined using a nasopharyngeal swab or aspirate, nasal swab plus a throat swab or nasal wash, or tracheal aspirate confirmed with a viral culture or real-time polymerase chain reaction (RT-PCR) procedure. In both cases this is a timely process, during which time any patient who actually has the virus could become seriously ill. The advantage of this home test for H1N1 is to provide a quick diagnosis so that treatment can be started ASAP, especially is H1N1 flu symptoms co-exist. The disadvantage is that false positives could results due to the sample being inadequate, a faulty device, or inadequate application of saliva.)
	16. Present Your Design	Be prepared to discuss your component and defend its use in a MEMS that can solve the problem stated in Procedure I: Step 2.